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| Application Number | 10581633 |
| Filing Date | 2006-06-02 |
| First Named Inventor | Takayuki Shima |
| Art Unit | 2627 |
| Examiner Name | |
| Attorney Docket Number | 690121.407USPC |

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|---|---|--------------------------|
| 1 | Neff, H. et al., "Structural, optical, and electronic properties of magnetron-sputtered platinum oxide films", Journal of Applied Physics, American Institute of Physics. New York, US, vol. 79, no. 10, 15 May 1996, pages 7672-7675, XP002463986. | <input type="checkbox"/> |
| 2 | Yi Chiu et al., "Fabrication and nonlinear optical properties of nanoparticle silver oxide films", Journal of Applied Physics, vol. 94, no. 3, 1 August 2003, pages 1996-2001, XP002479469. | <input type="checkbox"/> |

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